

In re the Application of

Petr VISCOR et al.

Application No.: 09/700,463

Filed: December 21, 2000

PLANAR ELECTRONIC EMITTER (PEE) For:

Docket No.: 107872

## INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- $\boxtimes$ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- $\boxtimes$ 2. References 7, 21, 24, 26 & 27 were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.
- $\boxtimes$ WO 94/14078 corresponds to European Patent No. 672257 which is cited in the specification.

Respectfully submitted,

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JAO:JSA/zmc

Date: February 13, 2001

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09/700,463

APPLICATION NO.

Form PTO-1449 (REV. 8-83)

## US Dept. of Commerce PATENT & TRADEMARK OFFICE

## INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

ATTY DOCKET NO. 107872

APPLICANTS
Petr VISCOR et al.

FILING DATE December 21, 2000

U.S. PATENT DOCU	MENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
EMS	1	4,303,930	12/01/1981	Van Gorkom et al.		
END	2	4,683,399	07/28/1987	Sociof	-	
EMF.	3	4,801,994	01/31/1989	Van Gorkom et al		
EMY	4	4,823,004	04/18/1989	Kaiser et al.		
MY	5	5,212,426	05/18/1993	Kane		
EMG	6	5,229,682	07/20/1993	Komatsu		
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## FOREIGN PATENT DOCUMENTS

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EM3	20	EP 0 150 885 A2	08/07/1985	Europe		_
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END	22	EP 0 504 603 A1	09/23/1992	Europe	)	)
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DATE CONSIDERED

Examiner:

Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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(Use several sheets if necessary)		several sheets if necessary)	APPLICANTS Petr VISCOR et al.				
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